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	Filing Date		2006-04-19		
	First Named Inventor	Karg	et al.		
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	1	Nanostructuring with laser radiation in the Physic Letters, Vol. 164, no. 1 29032, 199	nearfield of a tip from a scanning force microscope, 6-12-31	YAU ET AL, Applied				
	2	Selective area oxidation of silicon with a scanning force mircoscope, H.C. Day, et al, Applied Physic Letters, Vol. 62, 2691-2693, 1993-5-24						
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